

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Wen Lin, et al.

Serial No.:

10/814,682

Filed:

March 31, 2004

Title:

SEMICONDUCTOR DEVICE HAVING A DOPEDLATTICE MATCHING LAYER AND A METHOD OF MANUFACTURE

THEREFOR

Grp./A.U.:

2823

Examiner:

Julio J. Maldonado



Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

REQUEST FOR RECONSIDERATION UNDER 37 C.F.R. § 1.111

The Applicants have carefully considered this application in connection with the Examiner's Action and respectfully request reconsideration of this application in view of the following remarks. The Applicants originally submitted Claims 1-40 in the application. In a preliminary amendment to the application, the Applicants canceled Claims 1-20 and 28-36. Accordingly, Claims 21-27 and 37-40 are currently pending in the application.